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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:) Confirmation No.: 1232
)
Applicant: Baum, Thomas H., et al.) Docket No.: 2771-510
)
Application No.: 09/823,196) Examiner: Colleen E. Rodgers
)
Date Filed: March 30, 2001) Group Art Unit: 2813
)
Title: SOURCE REAGENT COMPOSITIONS FOR CVD FORMATION OF GATE DIELECTRIC THIN FILMS USING AMIDE PRECURSORS AND METHOD OF USING SAME) Customer No.: 25559
)

FACSIMILE TRANSMISSION CERTIFICATE

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Number of Pages



Tristan A. Fuierer

November 11, 2005

Date

**SUBMISSION OF AMENDMENT UNDER 37 CFR 1.312 IN UNITED STATES PATENT
APPLICATION NO. 09/823,196**

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

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In response to the August 25, 2005 Notice of Allowance in the above-identified application, please amend the application under the provisions of 37 CFR 1.312 as set out in the following **Section I (Amendments to the Claims)**.

Remarks are set out in the **Section II (Remarks)** hereof.